

8733.213.00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION Jin JANG et al

GAU: 2814

SERIAL NO: 09/497,508

EXAMINER: W. Louie

FILED: February 4, 2000

FOR: POLYCRYSTALLINE SILICON FILM CONTAINING Ni

REQUEST FOR EXTENSION OF TIME  
UNDER 37 C.F.R. 1.136

COMMISSIONER FOR PATENTS  
WASHINGTON, D.C. 20231

SIR:

It is hereby requested that a 3-month extension of time be granted to **November 21, 2001** for

- ☒ filing a response to the Official Action  
dated: May 21, 2001
- ☐ responding to the requirements in the Notice of  
Allowability dated:
- ☐ filing the Formal Drawings. The Issue  
Fee due
- ☐ responding to the Notice to File Missing Parts of  
Application dated:
- ☐ filing a Notice of Appeal. A timely response to the final  
rejection, due
- ☐ filing an Appeal Brief. A Notice of Appeal was  
filed on:
- ☐

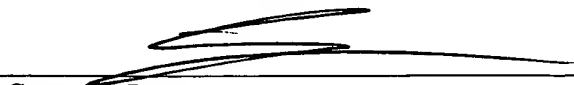
The required fee of **\$920.00** is enclosed herewith by check and any further charges may be made against the Attorney of Record's Deposit Account No. **50-0911**. A duplicate copy of this sheet is enclosed.

Respectfully Submitted,

LONG ALDRIDGE & NORMAN LLP

Date: November 20, 2001

Sixth Floor  
701 Pennsylvania Avenue, N.W.  
Washington, D.C. 20004  
Tel. (202) 624-1200  
Fax. (202) 624-1298

  
Song K. Jung  
Registration No. 35,210

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